

PATENT  
3313-1103P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: LIN, Yi-Xiong et al                      Conf.:  
Appl. No.: NEW    Group:  
Filed: January 29, 2004                              Examiner:  
For: POSITIONING AND MEASURING STATION FOR  
PHOTOELECTRIC ELEMENTS

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 29, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

Amendments to the Specification

Remarks